## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**XPPLICANT:** 

Spooner et al.

GROUP:

2813

**SERIAL NO:** 

10/007,585

**EXAMINER:** 

D. Hogans

FILED:

December 5, 2001

FOR: A METHOD AND DEVICE FOR PROTECTING MICRO ELECTROMECHANICAL

SYSTEMS STRUCTURES DURING DICING OF A WAFER

Assistant Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450 Mail Stop: Non Fee Amendment

Sir:

## **CHANGE OF CORRESPONDENCE ADDRESS**

Applicant's representative requests that the correspondence address for the above application be changed to:

Matthew E. Connors Gauthier & Connors LLP 225 Franklin Street, Suite 3300 Boston, MA 02110

Please note that effective January 1, 2004, this Firm has changed it's name from Samuels, Gauthier & Stevens LLP to Gauthier & Connors LLP.

Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Tradennaks, P.Q. Box 1450, Alexandria, YA\22313-1450, Mail Stop: Non Fee Amendment

Deborah M.

Date 12/9/04